	Application No.	Applicant(s)	- 1
Notice of Allowability	10/822,055	KIM ET AL.	
	Examiner	Art Unit	
	Michael P. Stafira	2877	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this apport of the communication GHTS. This application is subject to	plication. If not included will be mailed in due cour	se. THIS
1. X This communication is responsive to amendment filed 7/13	<u>/2006</u> .		:
2. ☑ The allowed claim(s) is/are <u>1-38</u> .			
<ol> <li>Acknowledgment is made of a claim for foreign priority un</li> <li>a)</li></ol>	•		
2. ☐ Certified copies of the priority documents have			
3. ☐ Copies of the certified copies of the priority doc			from the
International Bureau (PCT Rule 17.2(a)).		<b>3</b> - <b>1 1</b>	
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the require	ments
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give</li> </ol>			CE OF
5. CORRECTED DRAWINGS ( as "replacement sheets") mus	t be submitted.		
(a)  including changes required by the Notice of Draftspers	on's Patent Drawing Review ( PTO-	948) attached	
1)  hereto or 2)  to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the			k) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I</li> </ol>	sit of BIOLOGICAL MATERIAL r FOR THE DEPOSIT OF BIOLOGIC	nust be submitted. Note AL MATERIAL.	the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P	Patent Application	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary	• •	
3. ☐ Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Da 7. 🛛 Examiner's Amendr		•
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	<u> </u>	ent of Reasons for Allowan	ce
	9.  Other		
	5.		

# **DETAILED ACTION**

### **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

a. In claim 7, on page 4, line 1 delete"," after "particles" and insert -- on --.

## **Priority**

2. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

# **Drawings**

3. The drawings were received on July 13, 2006. These drawings are approved by the examiner of record.

# Allowable Subject Matter

- 4. Claims 1-38 are allowed over the prior art of record.
- 5. The following is an examiner's statement of reasons for allowance:

Application/Control Number: 10/822,055

Art Unit: 2877

Regarding claim 1, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having an emitter for irradiating light to the particles on the object in a direction substantially parallel to a surface of the object, the object being disposed on a stage and a detector for detecting the light emitted from the emitter of lights scattered from the particle, and in combination with the other recited limitations of claim 1. Claims 2-6 are allowed by the virtue of dependency on the allowed claim 1.

Page 3

Regarding claim 7, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having an emitter for irradiating a first light and a second light to the particles on the object being disposed on a stage in a first direction and a second direction which are substantially parallel to a surface of the object, the object being disposed on a stage and a detector for detecting the first and second lights emitted from the emitter of lights scattered from the particles and producing a first and second detection signals and a relative position signal between the emitter and the object, and in combination with the other recited limitations of claim 7. Claims 8-16 are allowed by the virtue of dependency on the allowed claim 7.

Regarding claim 17, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having a first driver for generating a first relative motion between the first emitter and the object to scan the surface of the object by the first light; a second driver for generating a second relative motion between the second emitter and the object to scan the surface of the object by the second light; a detector for detecting the first and second emitted lights or the first and second lights scattered from the particles, and for generating first and second detection signals to determine positions of the particles; and a data processor for

Art Unit: 2877

analyzing the first and second detection signals to determine positions of the particles, the first and second detection signals comprising a first relative position signal between the first emitter and the object and a second relative position signal between the second emitter and the object from the detector, and in combination with the other recited limitations of claim 17. Claims 18-19 are allowed by the virtue of dependency on the allowed claim 17.

Regarding claim 20, the prior art fails to disclose or make obvious a method for detecting particles located on an object having irradiating a light from an emitter to the particles on the object in a direction substantially parallel to a surface of the object and a detecting the light irradiated from the emitter or the light scattered from the particles employing a dome shaped detector disposed over the object, and in combination with the other recited limitations of claim 20. Claim 21 are allowed by the virtue of dependency on the allowed claim 20.

Regarding claim 23, the prior art fails to disclose or make obvious a method for detecting particles located on an object having the steps of irradiating a first light from an emitter to the particles on the object in a first direction substantially parallel to a surface of the object; generating a first relative motion between the emitter and the object during irradiation of the first light to scan the surface of the object with the first light; detecting the first light irradiated from the emitter or a first light scattered from the particle; generating a relative motion between the emitter and the object; irradiating a second light from the emitter to the particles in a second direction that is different from the first direction and is parallel to the surface of the object; generating a second relative motion between the emitter and the object during irradiation of the second light to scan the surface of the object with the second light; detecting the second light irradiated from the emitter or a second light scattered from the particles; and analyzing first and

Art Unit: 2877

second detection signals and a relative position signal between the emitter and the object created from detecting the first and second lights to recognize a position of the particles, and in combination with the other recited limitations of claim 23. Claims 24-28 are allowed by the virtue of dependency on the allowed claim 23.

Regarding claim 29, the prior art fails to disclose or make obvious a method for detecting particles on an object having the steps of irradiating a first light from a first emitter to particles on the object in a first direction substantially parallel to a surface of the object; generating a first relative motion between the first emitter and the object in a third direction different from the first direction during irradiation of the first light to scan the surface of the object by the first light; detecting the first light irradiated from the emitter or a first light scattered from the particles; irradiating a second light from a second emitter to the particle in a second direction that is different from the first direction and is substantially parallel to the surface of the object; generating a second relative motion between the second emitter and the object in a fourth direction different from the second direction during irradiation of the second light to scan the surface of the object by the second light; detecting the second light irradiated from the emitter or a second light scattered from the particles; and analyzing first and second detection signals to determine the positions of the particles, the first and second detection signals comprising a relative position signal between the emitter and the object created from detecting the first and second lights, and in combination with the other recited limitations of claim 29. Claims 30-31 are allowed by the virtue of dependency on the allowed claim 29.

Regarding claim 32, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having an emitter for irradiating light to the particles, the

Art Unit: 2877

object being disposed on a stage in a direction substantially parallel to a surface of the object and a detector for detecting the lights emitted from the emitter or lights scattered from the particle, wherein the detector is disposed over the object and has a dome shape, and in combination with the other recited limitations of claim 32.

Regarding claims 33-37, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having an emitter for irradiating a first light and a second light to the particles, the object being disposed on a stage in a first direction and a second direction which is substantially parallel to a surface of the object and a detector for detecting a first and second lights emitted from the emitter or the first and second lights scattered from the particles, and producing a first and second detection signals and a relative position signal between the emitter and the object, and in combination with the other recited limitations of claim 33-37.

Regarding claim 38, the prior art fails to disclose or make obvious an apparatus for detecting particles located on an object having an emitter for irradiating a first light and a second light to the particles, the object being disposed on a stage in a first direction and a second direction which is substantially parallel to a surface of the object and a dome shaped detector for detecting a first and second lights emitted from the emitter or the first and second lights scattered from the particles, and producing a first and second detection signals and a relative position signal between the emitter and the object, and in combination with the other recited limitations of claim 38.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

Application/Control Number: 10/822,055 Page 7

Art Unit: 2877

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michael P. Stafira whose telephone number is 571-272-2430. The examiner can normally be reached on 4/10 Schedule Mon.-Thurs..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Toatley can be reached on 571-272-2800 ext. 77. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Michael P Staffra Primary Examiner Art Unit 2877

September 20, 2006